

501.40475X00

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): TANAKA et al

Serial No.:

09/942,213

Filed:

August 30, 2001

For:

Method And Apparatus For Inspecting A Semiconductor Device

Group:

2812

Examiner:

## **PRELIMINARY AMENDMENT**

Assistant Commissioner for Patents Washington, D.C. 20231

December 27, 2001

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Sir:

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application.

## **IN THE SPECIFICATION:**

Please replace the original specification with the attached Substitute Specification.

## **IN THE ABSTRACT OF THE DISCLOSURE:**

Please replace the original abstract with the attached abstract.

TECHNULOGY CENTER 2800

JUL 17 2002